IBM DOCKET:

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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor:	Christopher E. Obszarny)	EXAMINER:
SERIAL NO.:)	ART UNIT:
FILING DATE:)	DATE: July 16, 1998
FOR:	APPARATUS AND METHOD FOR IN-SITU ADJUSTMENT)	

PROCESS

OF LIGHT TRANSMISSION IN A PHOTOLITHOGRAPHY

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Dear Sir:

In accordance with 37 CFR 1.56, 1.97 and 1.98, the following items are made of record to assist the Patent & Trademark Office in its examination of this application and is, in the opinion of the attorney designated below for applicant(s), information relevant to the closest prior art of which that person is aware. The filing of this Information Disclosure Statement shall not be construed as a representation that a search has been made or that no other art than that identified exists.

<u>PATENT NO.</u>	<u>INVENTOR</u>	ISSUE DATE
5,382,483	Young	1/17/95
5,464,713	Yoshioka et al.	11/7/95
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09//11/6395 09//11/6395 07/16/98 A copy of each of the foregoing items and Form PTO 1449 are enclosed herewith.

Respectfully submitted,

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CERTIFICATION OF MAILING UNDER 37 CFR 1.10

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